

Application for Approved User Status

Name (print): _____ **Email: (print)** _____

- Instrument:** Philips EM430 TEM, Room B18-B McNutt Hall
- Hitachi S-570 SEM, Room B18-F McNutt Hall
- Hitachi S-4700 FESEM, Room G-6 MRC

Requirements:

Instrument	Course Work	Experience	User Status	Initials	Date
Philips EM430	MET 414 – Transmission Electron Microscopy	6 hours of TEM use in the past 3 months	Supervised		
			Unsupervised		
Hitachi S-570	MET 313- Scanning Electron Microscopy & X-ray Microanalysis	6 hours of S-570 use in the past 3 months	Supervised		
			Unsupervised		
Hitachi S-4700	MET 313- Scanning Electron Microscopy & X-ray Microanalysis and/or In house S4700 Class	6 hours of S-4700 use in the past 3 months	Supervised		
			Unsupervised		

If supervised user, status will be upgraded to unsupervised user upon completion of:

This approved user status will remain in effect as long as a minimum of 20 hours of use is recorded in any 6 month period.

This approved status is granted with the understanding that, in the unlikely event that the instrument operator is unavailable due to unforeseen circumstances, the above named researcher may be asked to temporarily operate the instrument for other users who are not unsupervised users.

Any misuse of this privilege will result in revocation of this status. Misuse includes, but is not limited to, habitual tardiness for reserved sessions, missed reserved sessions, misuse of the instrument in any manner, or failure to log usage hours.

APPROVED:

_____ - _____ Date: _____ (Staff member responsible for instrument)
(print name) (signature)

_____ - _____ Date: _____ (Advisor)
(print name) (signature)

_____ - _____ Date: _____ (Director, AMCL)
(print name) (signature)

_____ - _____ Date: _____ (Director, Materials Research Center)
(print name) (signature)